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Solicitation Number: ITN 6744-3

Solicitation Title: Inductively Coupled Plasma Reactive Ion Etching

(ICP-RIE) System

Meeting Agenda: Award Decision Meeting

Start Date/Time (EST): 11/13/2025 at 11:00am EST.

Location: Via Zoom – Stephen Talevich is inviting you to a scheduled Zoom meeting.

Join Zoom Meeting

https://fsu.zoom.us/j/94329557412

Meeting ID: 943 2955 7412

One tap mobile

- +13052241968,,94329557412# US
- +16465588656,,94329557412# US (New York)

Join by SIP

• 94329557412@zoomcrc.com

Join instructions

https://fsu.zoom.us/meetings/94329557412/invitations?signature=TQYVsUwV2HDkpS64RhOWPa kfxD49xC3Zx4ow2-

Agenda: Award decision by consensus of committee

Matters to be considered are those identified in the agenda for said meeting.

Accommodations can be provided for special needs by email to Stephen Talevich at least 48 hours in advance.

Direct any questions to Stephen Talevich in Procurement Services at stalevich@fsu.edu.

